


<b>Search Notes</b>  	<b>Application/Control No.</b>  10526990	<b>Applicant(s)/Patent Under Reexamination</b>  MISHRA ET AL.
	<b>Examiner</b>  Rutkowski, Jeffrey M	<b>Art Unit</b>  2419

SEARCHED			
Class	Subclass	Date	Examiner
370	218, 252, 395, 422 (updated search)	12/30/2008	JMR
709	250 (updated search)	12/30/2008	JMR
370	357, 389, 392 (updated search)	12/30/2008	JMR
709	236 (updated search)	12/30/2008	JMR
370	225 (ge fe nic concepts)	12/30/2008	JMR

SEARCH NOTES		
Search Notes	Date	Examiner
searched EAST for ge fe nic concepts	12/30/2008	JMR
searched EAST for ge and fe selection concepts	12/30/2008	JMR

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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